



PATENTS

THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Michael TEWES ET AL. PCT EXAMINER: Shun K. Lee  
SERIAL NO: 09/319,092 GROUP: 2878  
FILED: JUNE 18, 1999  
TITLE: FLUORESCENCE CORRELATION SPECTROSCOPY MODULE FOR  
A MICROSCOPE

INFORMATION DISCLOSURE STATEMENT

MAIL STOP  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Applicant wishes to bring to the attention of the Patent Examiner the references listed on the enclosed Form PTO-1449. These references were cited in a Japanese Office action concerning a related application, copy enclosed. Copies of these references with English translations are enclosed. Since this Information Disclosure Statement is being filed after a first Office Action, the official fee of \$180.00 is enclosed to cover the fee for filing. The Commissioner is hereby authorized to charge Deposit Account No. 03-2468 for any additional fees or credit any overpayment in connection with this IDS. It is respectfully requested that the foregoing IDS be incorporated into the official file of the present patent application.

02/17/2006 SSESHE1 00000016 09319092

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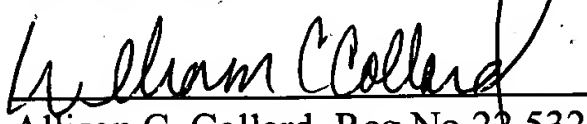
Enclosures: PTO-1449 form, six (6) references and check for \$180.00

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Mail Date: February 8, 2006

I hereby certify that this paper or fee is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR 1.10, on the date indicated above, and is addressed to the MAIL STOP: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Respectfully submitted,  
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FORM PTO-1449  
(REV. 7-80)U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE

ATTY. DOCKET NO.:

TEWES ET AL PCT

SERIAL NO.

09/319,092

LIST OF REFERENCES CITED BY  
APPLICANT

(Use several sheets if necessary)

APPLICANT: Michael TEWES ET AL

FILING DATE: June 18, 1999

GROUP: 2878

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						

## FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	AH	62-106365	05/1987	Japan w/abstract			X	
	AI	02-171712	07/1990	Japan w/abstract			X	
	AJ	08-043739	02/1996	Japan w/abstract			X	
	AK	07-199081	08/1998	Japan w/abstract			X	
	AL	08-136817	05/1996	Japan w/abstract			X	
	AM	08-068694	03/1996	Japan w/abstract			X	
	AN							
	AO							
	AP							

## OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

	AR		Japanese Office Action dated June 14, 2005
	AS		
	AT		

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.